



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No.: 10/054,697
Applicant: Walitzki et al.
Filed: January 18, 2002
TC/A.U.: 2822
Examiner Guerrero, M.

Confirmation No. 5401

\$2822
ED 1/3
#11
10/1/03

Docket No.: 4451-24-1 (formerly 020016-000311US)
Customer No.: 22442

For: "METHOD FOR FINISHING POLY-SILICON OR AMORPHOUS SUBSTRATE STRUCTURES"

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313

CERTIFICATE OF MAILING

I HEREBY CERTIFY THAT THIS CORRESPONDENCE IS BEING DEPOSITED WITH THE UNITED STATES POSTAL SERVICE AS FIRST CLASS MAIL IN AN ENVELOPE ADDRESSED TO COMMISSIONER FOR PATENTS, P.O. BOX 1450, ALEXANDRIA VA 22313-1450 ON SEPTEMBER 15, 2003.

SHERIDAN ROSS P.C.

BY: Sheridan Ross P.C.

REQUEST FOR EXTENSION OF TIME

Dear Sir:

Applicants, through attorneys, respectfully petition for an extension of time under 37 CFR § 1.136(a) of three (3) months to respond to the Office Action mailed on March 13, 2003, with respect to the above-identified application, thereby extending the period for response from June 13, 2003, to September 13, 2003.

Enclosed is a check in the amount of \$465.00 as payment for the extension fee. Please credit any overpayment or debit any underpayment to Deposit Account No. 19-1970.

Respectfully submitted,

SHERIDAN ROSS P.C.

By: Robert D. Traver

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Date: 15 Sept. 2003

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